

BEST AVAILABLE COPY

**REQUEST FOR RECONSIDERATION**  
**EXPEDITED PROCEDURE - G.A.U. 2827**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*Do not  
enter this  
amendment.  
2/17/04*

Applicants : Lawrence N. Crane et al.  
Application No. : 09/985,728  
Confirmation No. : 4228  
Filed : November 6, 2001  
Title : WAFER APPLIED FLUXING AND UNDERFILL  
MATERIAL, AND LAYERED ELECTRONIC ASSEMBLIES  
MANUFACTURED THEREWITH  
Group Art Unit : 2827  
Examiner : Alonzo Chambliss

MAIL STOP AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**FAX RECEIVED**

JAN 05 2004

**REQUEST FOR RECONSIDERATION** TECHNOLOGY CENTER 2800

Sir:

In response to the final Office Action of November 17, 2003, Applicants respectfully request reconsideration of the application based on the remarks set forth herein. As the present Request is submitted within two (2) months of the mailing date of the Office

<b><u>CERTIFICATE OF FACSIMILE TRANSMISSION</u></b>	
VIA FACSIMILE NO.: (703) 308-7722	
I hereby certify that this paper is being facsimile transmitted to the United States Patent and Trademark Office on the date shown below.	
Michelle Pichora (Typed Name of Person Signing Certification)	
Signature <i>Michelle Pichora</i>	Date 12/31/2003